

Image



2814

Attorney Docket No. 0756-2119

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hisashi OHTANI et al.

Serial No. 09/550,598

Filed: April 17, 2000

For: SEMICONDUCTOR DEVICE AND  
PROCESS FOR PRODUCING THE  
SAME

) Group Art Unit: 2814

) Examiner: P. Cao

) CERTIFICATE OF MAILING

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**AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 23, 2003, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.